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Patent

NOV 24 2006

Customer No.: 31561 Application No.: 10/604,651 Docket No. 10958-US-PA

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

**Applicant** 

: Peng et al. : 10/604,651

Application No. Filed

: August 7, 2003

For

: LOW TEMPERATURE POLYSILICON THIN FILM TRANSISTOR AND METHOD OF MANUFACTURING

THE SAME

Art Unit

: 2812

Examiner

: GHYKA, ALEXANDER G..

## TRANSMITTAL LETTER +1-571-273-8300

(Via fax: 1+2+15 pages)

ASSISTANT COMISSIONER FOR PATENTS Alexandria, VA 22314

Dear Sir,

In response to the Final Office Action dated August 24, 2006, please find the relevant papers as follows:

Request for Continued Examination in (2) pages;

Preliminary Amendment in (15) pages.

Thank you for your assistance in the subject matter. If you have any questions, please feel free to contact me.

Respectfully Submitted,

JIANQ CHYUN Intellectual Property Office

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